



PATENT  
81716.0122

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Isamu AKASAKI, et al.

Serial No: 10/810,309

Filed: March 26, 2004

For: SEMICONDUCTOR APPARATUS,  
METHOD FOR GROWING NITRIDE  
SEMICONDUCTOR AND METHOD  
FOR PRODUCING SEMICONDUCTOR  
APPARATUS

Art Unit: 2811

Examiner: Not Assigned

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**STATUS REQUEST**

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Dear Sir:

This application was filed on March 26, 2004 and receipt by the U.S. Patent and Trademark Office was acknowledged in the Filing Receipt dated June 7, 2004. However, no Office Action has yet been received. Accordingly, Applicants request to be advised of the status of the application, including an indication of when the patent application is expected to be examined.

Please send the undersigned a Status Report on this application.

Respectfully submitted,  
HOGAN & HARTSON L.L.P.

Date: May 27, 2005

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